

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masayuki SUZUKI et al.

Application No.: 10/670,337



Filed: September 26, 2003

Docket No.: 117330

For: HEATER INSPECTION APPARATUS AND SEMICONDUCTOR MANUFACTURING
APPARATUS HAVING HEATER INSPECTION APPARATUS MOUNTED THEREON

INFORMATION DISCLOSURE STATEMENT

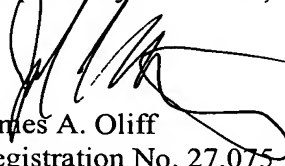
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language reference is discussed in the present specification. (Ref.1)
- ☒ 3. An English-language Abstract of the non-English language reference is attached hereto. (Ref. 1)

Respectfully submitted,


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Date: April 2, 2004

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

Sheet 1 of 1

Form P-1149 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 117330		APPLICATION NO. 10/670,337	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Masayuki SUZUKI et al.			
				FILING DATE September 26, 2003			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1	JP A 4-155828 w/ abst	05/28/1992	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: April 2, 2004